## CLAIMS

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- 1. A multicrystalline silicon substrate comprising: a substrate of multicrystalline silicon having relatively large irregularities formed on a surface thereof by etching with an alkaline aqueous solution; and
- a multiplicity of relatively fine textures formed by dry etching over the relatively large irregularities,

wherein a ratio r expressed as r=a/b, which is the ratio between the length a of a virtual line connecting individual peaks of the relatively fine textures at a vertical cross section thereof and the length b of a straight line connecting the endpoints of the virtual line, is equal to or larger than 1 and smaller than 1.1.

- 15 2. The multicrystalline silicon substrate according to claim 1, wherein the fine textures have a height and a width of  $2\,\mu\,\mathrm{m}$  or less, respectively.
- 3. The multicrystalline silicon substrate according to claim 1, wherein the fine textures have a height and a width of  $1\mu\,\mathrm{m}$  or less, respectively.
  - 4. The multicrystalline silicon substrate according to claim 1, wherein the fine textures have a height-to-width aspect ratio (height/width) of 2 or less.

5. A process for roughening a surface of a multicrystalline silicon substrate comprising the steps of:

etching a surface of a multicrystalline silicon substrate with an alkaline aqueous solution for forming relatively large textures having a surface area-to-planar surface area ratio R of larger than 1 and smaller than 1.1; and

a dry etching step for forming a multiplicity of relatively fine textures over the relatively large irregularities.

6. The process for roughening a surface of a
multicrystalline silicon substrate according to claim
5, wherein in the step of forming a multiplicity of
relatively fine textures, a ratio r expressed as r=a/b,
which is the ratio between the length a of a virtual line
connecting individual peaks of the relatively fine
textures at a vertical cross section thereof and the
length b of a straight line connecting the endpoints of
the virtual line, is equal to or larger than 1 and smaller
than 1.1.